



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the application of: Wilk *et al.*

Serial No.: 09/176,422

Filed: 10/21/98

For: Low Temperature Method for Forming a Thin, Uniform Oxide

Docket:

TI-24742

Examiner:

N. Berezny

Art Unit:

2823

#10
3-7-01
C. Brown

**NOTICE OF APPEAL FROM THE PRIMARY EXAMINER TO THE BOARD OF
PATENT APPEALS AND INTERFERENCES**

MAILING CERTIFICATE UNDER 37 C.F.R. § 1.8
I hereby certify that this correspondence is being deposited with the
United States Postal Service as first class mail in an envelope
addressed to: Assistant Commissioner for Patents, Washington,
DC 20231 on

February 28, 2001.

Tina Rendon
Tina Rendon

February 27, 2001

Assistant Commissioner for Patents
Washington, D. C. 20231

Examiner:

Applicant appeals to the Board of Appeals from the Primary Examiner's decision dated
December 6, 2000, which finally rejected Claims 1 - 25.

03/07/2001 AJOHNS01 00000003 200668 09176422
01 FC:119 Account No. 20-0668. Two additional copies of this notice are enclosed.

Respectfully submitted,

David Denker
David Denker
Reg. No. 40,987

Texas Instruments Incorporated
P. O. Box 655474, MS 3999
Dallas, Texas 75265
(972) 917-4388
Fax (972) 917-4418

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